



<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> (use as many sheets as necessary)		<b>Complete if Known</b>	
		Application Number	10/753,384
		Filing Date	January 9, 2004
		First Named Inventor	Hisao IKEDA
		Art Unit	2879
Examiner Name	Peter J. Macchiarolo		
Sheet 1 of 1	Attorney Docket Number	740756-2698	

U.S. PATENT DOCUMENTS					
Examiner Initials <sup>*</sup>	Cite No. <sup>1</sup>	U.S. Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code <sup>2</sup> (if known)			
PM		US-5,989,737	11/23/1999	XIE et al.	
PM		US-2003/0129447	07/10/2003	MADATHIL et al.	
		US-			
		US-			
		US-			

FOREIGN PATENT DOCUMENTS						
Examiner Initials <sup>*</sup>	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>3</sup>
		Country Code <sup>3</sup> Number <sup>4</sup> Kind Code <sup>2</sup> (if known)				
PM		EP-1296386	03/26/2003	MADATHIL et al.		Full
		JP-07-045367	02/14/1995	NOMA et al.		AB
		JP-10-255985	09/25/1998	SHOAN et al.		AB
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		JP-2001-284059	10/12/2001	AIKAWA et al.		AB
		JP-2003-109770	04/11/2003	MADATHIL et al.		AB

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials <sup>*</sup>	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>3</sup>
PM		Search Report and Written Opinion (Application No. PCT/JP2004/010187; PCT7268) Dated: 09/07/2004 with translation of Search Report and Written Opinion	
		NAKANISHI et al., "Doping Effect and Conduction Mechanism of Organic Semiconductor Evaporated Films", TECHNICAL REPORT OF IEICE..., OME2000-108 (2000-09) with Full Translation	
		TSUCHIYA et al., "Manufacturing Method of Light Emitting Element", U.S. Serial No. 10/894,346, Filed: July 20, 2004 (Specification, Claims, Drawings and Filing Receipt)	

Examiner Signature	<i>Peter J. Macchiarolo</i>	Date Considered	3-23-05
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> See Kinds Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov) or MPEP 901.04. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.